

EXPERIENCE WITH HIGH CHARGE PHOTOINJECTOR OPERATION AT THE ARGONNE WAKEFIELD ACCELERATOR FACILITY.



JOHN POWER Argonne Wakefield Accelerator, Argonne National Laboratory



July, 21, 2020 Joint DESY and University of Hamburg Accelerator Physics Seminar

ARGONNE WAKEFIELD ACCELERATOR (AWA)

The AWA's mission: R&D for future accelerators



- 5 accelerators at Argonne
- 30 minutes west of Chicago.
- Visitors Welcome!!



OUTLINE

- Introduction to AWA
 - Group & facility
 - Science
 - Beam parameters
 - Experiments
- AWA experience with high charge photoinjectors
 - Focus on practical lessons learned at AWA (80%)
 - Leave simulation work to PETRA-IV (20%)
- Summary/discussion



WHO WE ARE

THE AWA GROUP





THE AWA GROUP





THE AWA STUDENTS

Tsinghua Tsinghua IIT IIT





Lianmin Zheng

2018

Nicole Neveu

2018



Gongxiaohui Chen current



Maomao Peng current

*All of these AWA students reside at Argonne.

*AWA students are often Pl's on the AWA's core R&D

UNIST MSU UCLA NIU UW UPR













Tamara Gonzalez Acevedo Mitchell Schneider





Ryan Roussel

Jens Carter







Jimin Seok









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current

ARGONNE COMMUNITY

Scientific collaboration inside ANL (multipurpose lab)

- Argonne Accelerator Institute (John Byrd)
 - 1. APS (Advanced Photon Source): <u>https://www.aps.anl.gov/</u>
 - 2. ATLAS (Argonne Tandem Linac Accelerator System) in PHYS: https://www.anl.gov/atlas
 - 3. AWA (Argonne Wakefield Accelerator) in HEP: https://www.anl.gov/awa
 - 4. LEAF (Low Energy Accelerator Facility) in Nuclear Engineering: <u>https://www.ne.anl.gov/facilities/leaf/</u>
 - 5. EXM (Electron and X-ray Microscopy) in CNM: https://www.anl.gov/cnm/electron-and-xray-microscopy
- Math & Computer Science: efficient optimization, machine learning, ...
- "User" Applications: MSD (beam irradiation of samples), APS (radiation for medical therapy studies)

Technical expertise inside ANL (multipurpose lab)

- HEP: Electronics Group, Mechanical Group, Safety
- ANL Central Shops: machining, brazing, welding, metrology
- APS: Vacuum Shop (UHV cleaning), Ju Wang (high-voltage test of beam kicker, and bipolar supplies), Alex Cours (klystron modulator circuits), Jeff Dooling (laser diagnostics),
- PHY: (radiation shielding calculations for AWA bunker);
- Other ANL divisions: CNM (Ultrananocrystalline Diamond for cathodes); ES and CSE: (atomic layer deposition (ALD) to prevent multipacting); ES (tribology and metrology for ILC positron source) CNM (SEM for surface inspection)





AWA COLLABORATORS AND CONTRIBUTORS



WHO WE ARE

AWA FACILITY - BEAMS - EXPERIMENTAL AREAS





AWA FACILITY

Highly reconfigurable beamlines

- Zones 2-5 are experimental areas
- Zones 2, 4, and 5 have ~ 1 m experimental area
- Zones 3A & 3B are fully re-configurable





AWA FACILITY



AWA CAPABILITIES - BEAMS

Wide dynamic range

SINGLE BUNCH PARAMETERS

Beam parameters	Value	Note	
Charge [nC]	0.1 -100	*Have generated sub-pC beam but difficult to detect.	
Energy [MeV]	6 - 63		
Rep. rate [Hz]	0.5 – 10	*2 Hz is nominal	
Transverse laser diameter [mm]	0.5 - 22	*Uniform distribution (MLA)	
Longitudinal laser pulse length [ps FWHM]	0.3	*Gaussian distribution **Flattop distribution (using α-BBO)	
Bunch length [mm]	0.1 - 3	*High charge compression is not available	
Transverse emittance [µm]	0.5 - 240	nancake	
Peak Current [kAmps]	0.5 - 25		
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AWA CAPABILITIES - BEAMS

Variable Machine Configurations

Operation modes	Value		Methods	
Bunch train	Modulation frequency [GHz]	1.3 – 10 ³	 Laser multi-splitter Alpha-BBO EEX+mask EEX+transverse wiggler TDC+mask (R&D) 	
	Charger per bunch [nC]	<60		
Longitudinal shaping	Shape	Arbitrary	 1. EEX 2. TDC (R&D) 3. Laser based (R&D) 	
	Charge [nC]	<5 ightarrow <20		
Flat beam	Charge [nC]	<5	 Angular momentum dominated beam + skew quads 	
	Emittance ratio	<150		
Transverse shaping	Available type	 Homogenization Dot-array Hollow 	1. MLA optics	
		13		

WHAT WE DO

AWA SCIENCE





AWA SCIENCE

~50/50 between in-house research & collaborators



AWA is not a user facility.

AWA & collaborators work together closely. (we don't merely provide beam.)



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AWA MISSION

Developing the science and technology of electron beam generation, manipulation and acceleration for **electron beam-driven wakefield acceleration** and other applications.

Advanced Accelerator Concepts	Accelerator and Beam Physics	Electron Source	Stewardship
 Wakefield acceleration >300 MeV/m acceleration 1 GV/m structure test High efficiency acceleration Double rf-beam efficiency High power generation 1 GW rf power extraction SWFA/PWFA ~90/10 Breakdown studies 	 Large parameter space for tunable beamline 6D phase space manipulation. shaping, patterned beams. Instability suppression. Novel Diagnostics. 	 High QE Cs₂Te cathode fabrication and operation FE cathode testing. Emittance correction (coupled-transverse-dynamicsaberration) 	 UED/UEM Advanced cathode testing Collaboration work for future light sources Structure, beam physics, and source knowhow to medical/industrial applications





AWA – HIGH TRANSFORMER RATIO





 $\mathcal{R} = 7.8^{+2.5}_{-1.7}$

PWFA Record

R. Roussel, et al, PRL 124, 044802 (2020)

 $\mathcal{R} = 4.9 \pm 1.5$

SWFA Record

Q. Gao, et al, PRL 120, 114801 (2018)





AWA DIAGNOSTICS

*G. Ha et al., in preparation (2019)





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HIGH CHARGE PHOTOINJECTORS

- DESIGN CONSIDERATIONS
- RUNNING EXPERIENCE





AWA HIGH CHARGE DRIVE PHOTOINJECTOR



Gun design considerations

- Avoid laser damage of photocathode
- Avoid Space Charge limited emission
- Avoid scraping laser on the way in
- Avoid scraping electrons on the way out.
- Minimize vacuum pressure rise
- Minimize beam loading

- Acceleration cavity design considerations
 - Minimize beam loading
 - Avoid scarping electrons
 - Minimize vacuum pressure rise





AVOID DAMAGE THRESHOLDS: EXPLOSIVE EMISSION

Original AWA drive gun



https://accelconf.web.cern.ch/p95/ARTICLES/WPB/WPB11.PDF http://accelconf.web.cern.ch/e98/PAPERS/TUP33C.PDF



Explosive emission when laser energy density < 10mJ/cm2 (0.1 mJ/mm2)

Need larger laser spot

Longer laser pulse?

21

Experimental

Issue

AVOID DAMAGE THRESHOLDS: LASER CLEANING

Energy Density of Metal Cleaning Laser [mJ mm⁻²] Copper Magnesium 0.1Niobium 0.6 Lead 0.2

clean ... without altering the surface finish

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E = hv (remember)

(Dowell & Rao, An Engineering Guide To Photoinjectors) https://arxiv.org/abs/1403.7539



Cs2Te?

- Cathode center \rightarrow
- "We explain this by laser
- cleaning of the cathode surface"

FLASH. FEL2017 https://accelconf.web.cern.ch/fel2017/papers/wep003.pdf

FLASH

Metals well known.

Cs2Te?

e.g. Mg: E < 10 mJ/cm2

$Ec = 52 \text{ MV/m} (\alpha = 1.86), 1 \text{ nC}, E = 50 \text{ nJ}, QE = 10$ %, Laser sigZ 6.5 ps (peak power of 3 kW only); Laser dia. = 1.2 mm (fluence **4.4 mJ/cm2**)

"far away from typical damage thresholds of a few J/cm2. These are all reasonable low laser power values which eases the design of the laser system and, damages or ablations of optical components or of the cathode thin film itself are avoided."



Experimental

lssue

Avoid Space Charge (SC) limited emission

simulation Issue

Threshold



51 mm

2005: Gun2 1.5 cell gun with Mg 2011: Gun2 1.5 cell gun with Cs2Te 2021: Gun3: RF symmetrized



Eiris/Ecath = 1.04

48 mm

K.....

24 mm

35 MM

Polished surface



Experimental Issue



*note: gun was RF conditioned to 88 MV/m with Cu cathode

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Before conditioning

"RF-off" base vacuum = ion gauge reading in the gun was 2.0×10⁻¹⁰ Torr 2. 70 MV/m



- 1. After: 120 hrs & 60 MV/m
 - Slow RF conditioning
 - No arcing <4 nC
 - Strong arcing >4nC, 4×10⁻⁹
 - Strong arcing at "wrong" phase
- - Rc=22mm
 - Improved laser profile
 - No arcing 100 nC, 4×10⁻¹⁰



Experimental Issue

Careful cathode plug design Rounded edges to reduce arcing, less trips, less vacuum rise





After 1 year with high QE, fast RF conditioning, and no arcing problem



E. Wisniewski, NAPAC16 http://accelconf.web.cern.ch/napac2016/papers/wepob19.pdf



Gun summary

Challenge: High charge means high laser energy and lots of e- spray **Solution**:

- Avoid arcing and vacuum base pressure rise
 - Arcing \rightarrow Vacuum pressure burst
 - High laser intensity can cause
 - explosive emission
 - -laser cleaning

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- Careful cathode plug design
- Vacuum pressure rise \rightarrow e- hitting wall
 - Halo/Spraying electrons (SC limited emission)
 - Scraping electrons on the way out.

Beam loading? (1.3GHz stored energy = 27.2 J; Beam = 20nC*6MeV = .12J)

- Need large laser diameter
 - Homogenized laser

- Need high Ec field
- Need large apertures



RF CAVITY DESIGN CONSIDERATIONS



MULTIBUNCH WAKEFIELD EFFECTS AND ITS MITIGATION



Bunch #

AWA LARGE APERTURES

Avoid scraping laser on the way in (allows for large laser spot) Avoid scraping electrons on the way out



AWA LASER INPUT Laser Multisplitter (50-50 beam splitters, waveplates, attenuators

Developed in house using off-the-shelf parts

- $\circ\,$ selectable bunches and combinations
- $\circ\,$ delay stages
- $\circ\,$ alignment capability for individual delay leg
- $\circ\,$ selectable charge from 10 pC to 100 nC
- o Generation of single, 2, 4, 8, 16 or 32 bunch trains











AWA PHOTOINJECTOR PERFORMANCE

1. Drive linac: commissioning underway

installation complete

In-flange FCT-ICT from Bergoz 02 Variable duration = 6 - 12 ns 0.05 Fast CT signal 16 bunches 769 ps 0.00 () Iduy -0.05 Feb 20, 2014 Energy: 19 MeV -0.10 • Variable charge: 100 nC \rightarrow 560 nC (odd pulses shown) Trains: 16 x 35nC (Previous record 4 x25nC) -0.15 1 2 3 4 5 13 14 15 16 17 12.3 ns 25 🗲 6.1 ns 놀 Integrating ICT pulse (V) 20 Qtrain=560 nC CT signal 8 bunches 0.2 Qbunch=35 nC 0.1 15 0.0 -0.1 10 -0.2 -0.3 5 -0.4 -0.5 50 100 150 200 CT = Current Transformer time (ns) U.S. DEPARTMENT OF ENERGY Argonne National Laboratory is a U.S. Department of Energy laboratory managed by UChicago Argonne. LLC

Lesson learned:

High charge propagation is vacuum limited

DOE Review

2015

Improvements:

- beam alignment,
- laser alignment, •
- laser profile
- Install getter pumps

Current AWA record

- 660 nC
- 8x82nC in 6.25 ns
- 5.2 J Gun, 6.6 J Cavity
- 100nC, 25 kA



AWA L-BAND TEST STAND

Testing photocathodes and field emission

700 MV/m



Field emission

Stored energy dependence
In-situ field emission imaging
In-situ BD location observation

J. Shao, et al, PRL 115, 264802 (2015) J. Shao, et al, PRL 117, 084801 (2016)



INJECTOR COMPARISON

AWA

- 1.3 Ghz L-band photocathode & L-band linac
- Cathode diameter = 31mm
- microbunch Q = 160 nC
- Train = 8x82nC (660 nC, 6.25 ns)
- G4 at AWA will be ~27.2 J
- Beam = 5.2 J Gun (19%)
- Last bunch in train probably create halo do to drop in Ec due to beamloading

S. Döbert, CERN; PHIN S-band photoinjector, EPAC 2006 (told me they achieved 60nC om S-band)

PETRA IV

- 3 Ghz S-band photocathode & S-band linac
- Cathode diameter = ?
- microbunch Q = 22 nC
- Train = 6x7.5nC (45 nC, 1.67 ns)
- Stored energy of the S-band gun at Tsinghua is ~1.8 J
- Beam = 45nC*6MeV = .27J (15%)
- Energy droop in train → affects transport





6x7.5 = 45nC

3 GHz

0.5 GHz

EXAMPLE OF 20 NC INJECTOR FOR APS





PREVIOUS DESIGN STUDY FOR 20NC INJECTION INTO APS BOOSTER B F Sol Simulations: Han Chen Grad. Student. Tsinghua







OPTIMIZATION SETTINGS

I use a NSGA-II genetic algorithm and ASTRA to optimize and simulate the beam dynamics. Some settings are as the followings.

- Thermal emittance 0.75mmmrad/mm, Charge 20nC
- Uniform transverse distribution, 20ps FWHM flattop laser pulse, rising time of 2ps
- Maximum field in the gun is 70MV/m, energy gain about 7MeV
- Maximum field in the linac is 25MV/m, energy gain about 12MeV
- The center of BF solenoid is the cathode surface.
- The center of M solenoid is set to be about 0.25m, taking installation space into consideration.









SUMMARY & DISCUSSION





SUMMARY: HIGH Q ISSUES

Vacuum

- AWA high Q operation is vacuum limited (base pressure tripping and arcing)
- Avoid electrons hitting the wall
 - Halo and SC limited emission
 - Laser, use multi-splitter instead of 2ns laser
- Lots of pumping
- Avoid laser ablation (explosive emission & laser cleaning)
- Beam dynamics
 - large transverse laser spot & long laser pulse, therefore, higher emittance
 - Optimize for low electron loss with acceptable beam parameters for booster
 - Minimize beam loading (Design issue)
 - Over-coupled beta will not help with short train
 - beam loading compensation
 - Frequency or Time domain compensation
 - AWA: High Stored Energy: Adjust launch phase so each bunch "sees" ~same Ec
- Radiation?
 - low rep rate so AWA is not limited by radiation.
 - PETRA-IV is also low rep rate (2 Hz) so probably no radiation issues



SUMMARY: PRACTICAL CONSIDERATIONS

LASER

- Use large laser transverse spot \rightarrow Need large diameter photocathode
- Maximize clearance for injection of large laser spot (from input mirror to photocathode)
 - AWA >10cm except two tight spots, gun exit pipe and laser input mirror
- Move laser input mirror far off axis (Distance between laser input mirrors: gap = 6.35 cm)
- Use long laser pulse. (Probably, Lacking experimental data,)
- Avoid hot spots in laser

• GUN

- High Ec field & phase far from e- loss (AWA student thesis: "right" phase = 55-85)
- Large photocathode
- Large aperture on gun iris; Gun exit pipe (length= 10cm): dia.=5cm

LINAC

- Large diameter irises and beam pipes

SIMULATIONS

- Good tools available for single beam, but we need a way to simulate beam bunch trains (RF period)
 - SC, CSR, short range wake, AND long range wake, Several codes have the first 3 but cannot add in the long range wake (many RF periods) while keeping SC mesh etc.

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